



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1756  
Examiner: Kathleen Duda

17568

10/22/02  
#6/RT  
(amw)

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OCT 21 2002

TC 1700

In Re PATENT APPLICATION Of:

Applicant(s) : Minoru WATANABE

Serial No. : 10/025,783

Filed : December 26, 2001

For : METHOD AND APPARATUS FOR  
FORMING RESIST PATTERN

Attorney Ref. : MAE 223 C1

PETITION FOR  
EXTENSION  
OF TIME

October 16, 2002

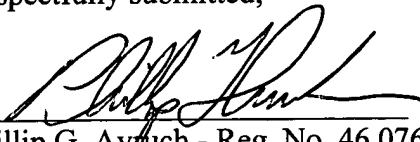
Commissioner of Patents  
Washington, D.C. 20231

Sir:

Please extend the period for responding to the Office Action of May 22, 2002 by two (2) months, and thus until October 22, 2002. The requisite extension fee of \$400 is being submitted concurrently. Should this fee be accidentally missing, however, or should any additional fees be required (including additional extension of time fees), the Commissioner may charge such fees to our deposit account number 18-0002.

Respectfully submitted,

October 16, 2002  
Date

  
Phillip G. Avzuch - Reg. No. 46,076  
RABIN & BERDO, P.C.  
Telephone: 202-371-8976  
Telefax: 202-408-0924  
CUSTOMER NO. 23995

PGA:tl

FEES ENCLOSED: \$400.  
Please charge any further  
fees to our Deposit Account  
No. 18-0002

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